



#14/c

UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)	<u>PATENT APPLICATION</u>
)	
Inventor: Wei Pan, Yoshi Ono, David R. Evans, and Sheng Teng Hsu)	April 29, 2003
)	
Serial No.: 09/819,296)	ATTORNEY DOCKET
)	No. SLA0515
)	
Filed: March 27, 2001)	Group Art Unit: 2811
)	
Title: MULTI-LAYERED BARRIER)	Examiner: Hung K. Vu
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REQUEST FOR CONTINUED EXAMINATION AND
RESPONSE UNDER 37 C.F.R. § 1.114

Hon. Commissioner for Patents
Washington, D.C. 20231

Sir:

This amendment and request for continued examination responds to a final Office Action dated December 31, 2002 in the above-identified application.

Please amend the application as follows:

IN THE CLAIMS:

Please amend claims 8, 14, and 21 by rewriting the claims to the following: